

IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.: Not Yet Assigned

PATENT

Filing Date: Herewith

Attorney Docket No. 101453-00067 SP101

Inventor(s): Venkat SELVAMANICKAM et al.

Group Art Unit: Not Yet Assigned

Examiner Name: Not Yet Assigned

Customer No.: 27160

Title: APPARATUS FOR AND METHOD OF
CONTINUOUSHTS TAPE BUFFER
LAYER DEPOSITION USING LARGE
SCALE ION BEAM ASSISTED
DEPOSITION

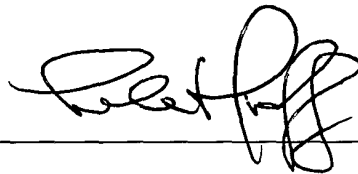
Mail Stop _____
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST TO MAKE SPECIAL

Pursuant to 37 CFR 1.102 applicants hereby request the USPTO to accelerate the processing of the above identified application for patent. The captioned application for patent relates to superconductive materials, processes and techniques for their manufacture and/or use and is within the scope of the Presidential mandate to accelerate prosecution of applications involving superconductivity.

Respectfully submitted,

By: _____



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